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Reply under 37 C.F.R. 1.116
Expedited Procedure
Technology Center 2814

Confirmation No. 1784

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	VAN DAL, <i>et al.</i>	Examiner:	Ingham, John C.
Serial No.:	10/575,288	Group Art Unit:	2814
Filed:	April 11, 2006	Docket No.:	NL031259US1
Title:	SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING SUCH A SEMICONDUCTOR DEVICE		

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No. 65913

Dear Sir:

In acknowledgement of the Final Office Action dated November 17, 2008, please reconsider the application in view of the remarks.

A complete listing of the claims and Remarks/Arguments follow.

**Authorization is provided to charge/credit Deposit Account 50-0996
(NXPS.548PA) any requisite fees/overages to enter this paper.**